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Docket No.: 8733.874.00
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
KWON, Oh-Nam, et al.

Application No.: 10/685,419

Confirmation No.: 5831

Filed: October 16, 2003

Art Unit: 2817

For: ARRAY SUBSTRATE HAVING DOUBLE-
LAYERED METAL PATTERNS AND
METHOD OF FABRICATING THE SAME

Examiner: Hoan C. Nguyen

STATUS INQUIRY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

It is respectfully requested that the attorney named below be advised of the status of the above-identified application. Please advise us of when we might expect to receive an Office Action from the Patent and Trademark Office.

Dated: March 15, 2005

Respectfully submitted,

By Valerie P. Hayes
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